



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 31, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG743594667

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

9.77 - 9.83 X 5.97 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

3.50 CARATS

E

VS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

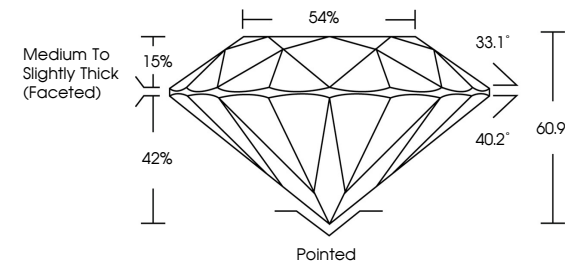
EXCELLENT

NONE

IGI LG743594667

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

54%

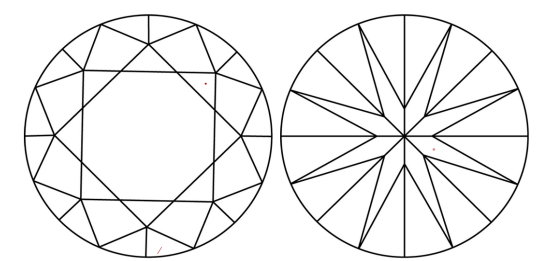
33.1°

40.2°

60.9%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J

Faint

Very Light

Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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ROUND BRILLIANT

9.77 - 9.83 X 5.97 MM

Carat Weight

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Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

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Inscription(s)

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VS 1

IDEAL

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EXCELLENT

EXCELLENT

NONE

IGI LG743594667

Cutler

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